



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:)
Satoshi Tanaka et al.) Group Art Unit: 2825
Application No.: 10/808,299)) Examiner: MEMULA, Suresh
Filed: March 25, 2004))
For: SET OF MASKS, METHOD OF GENERATING MASK DATA AND METHOD FOR FORMING A PATTERN) Confirmation No.: 7279))
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	,
Sir:	

PETITION FOR EXTENSION OF TIME

Applicants petition for a three month extension of time to file a reply to the Office Action of August 15, 2006. A fee of \$1,020.00 is enclosed.

Please grant any additional extensions of time required to enter the attached reply and charge any additional required fees to Deposit Account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: February 12, 2007

Richard V. Burgerjían Reg. No. 31,744

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